

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Lin, Shih-Yen; Tang, Shiang-Feng; Lee, Si-Chen; Kuan, Chieh-Hsiung
Assignee: National Science Council
Title: Quantum Dot Infrared Photodetector And Method For Fabricating The Same
Serial No.: Unknown Filing Date: Herewith
Examiner: Unknown Group Art Unit: Unknown
Docket No.: AB-1133 US

San Jose, California
April 30, 2001

Box Patent Application
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

PRELIMINARY AMENDMENT

Dear Sir:

Before examination on the merits, please amend the above application as follows:

IN THE CLAIMS

11. (Amended) The method according to claim 10, wherein said second undoped aluminum gallium arsenide layer has a thickness of about 50 nm.

In accordance with 37 CFR § 1.121(c)(1)(ii), Appendix A provides a marked up version of the claim containing the newly introduced change.

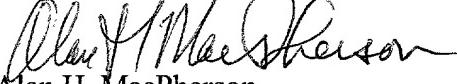
REMARKS

Claims 1-22 are pending. Claim 11 has been amended to correct a typographical error. Entry of this Preliminary Amendment is respectfully requested.

EXPRESS MAIL LABEL NO:

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Respectfully submitted,


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APPENDIX A

In the following, insertions are underlined and deletions are enclosed in brackets.

11. (Amended) The method according to claim 10 [11], wherein said second undoped aluminum gallium arsenide layer has a thickness of about 50 nm.

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